**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Bailey III et al.

Attorney Docket No.: LAM1P123/P0557

Application No.: 09/470,236

Examiner: Alejandro Mulero, Luz L.

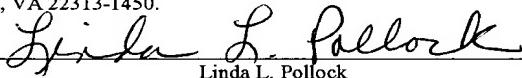
Filed: November 15, 1999

Group: 1763

Title: PLASMA PROCESSING SYSTEM WITH  
DYNAMIC GAS DISTRIBUTION CONTROL Confirmation No. 5922**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on July 22, 2005 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed:

  
Linda L. Pollock**AMENDMENT G**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed April 22, 2005, please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

**Remarks/Arguments** begin on page 12 of this paper.